## WHAT IS CLAIMED IS:

1. A method of manufacturing a flowing junction reference electrode, the method comprising:

providing a chamber for receiving a reference electrolyte solution, wherein the chamber is configured to allow pressurization of the electrolyte solution; and

providing a liquid junction member having N discrete nanochannels, the nanochannels having diameters D and lengths L, wherein N is less than approximately 100,000, and wherein the member is in fluid communication with the electrolyte solution.

- 2. The method of Claim 1, further comprising filling said chamber with a reference electrolyte solution having a viscosity  $\eta$  and pressurizing the electrolyte solution to a pressure  $P_E$ .
- 3. The method of Claim 2, wherein the electrolyte solution comprises a surfactant.
- 4. The method of Claim 2, further comprising configuring the reference electrode such that the liquid junction member can be brought into fluid communication with a sample solution such that the junction member is situated between the electrolyte solution and the sample solution.
- 5. The method of Claim 4, further comprising selecting  $\Delta P$ , D,  $\eta$ , and L  $\frac{D^2 \Delta P}{32 \eta L}$  such that  $\frac{D^2 \Delta P}{32 \eta L}$  is greater than about 0.1 centimeter per second, wherein  $\Delta P$  is a pressure differential between  $P_E$  and a pressure  $P_S$  of the sample solution.
- 6. The method of Claim 5, wherein  $\Delta P$  is greater than approximately 10 psi and less than approximately 100 psi.
  - 7. The method of Claim 5, wherein  $\Delta P$  is less than approximately 70 psi.
  - 8. The method of Claim 1, wherein N is less than approximately 50,000.
  - 9. The method of Claim 1, wherein N is less than approximately 10,000.
  - 10. The method of Claim 1, wherein N is less than approximately 1,000.
  - 11. The method of Claim 1, wherein N is greater than approximately 10.

- 12. The method of Claim 1, wherein N is greater than approximately 100.
- 13. The method of Claim 1, wherein a diameter  $D_i$  of any one nanochannel is substantially equal to a diameter  $D_i$  of any other nanochannel.
- 14. The method of Claim 1, wherein D is greater than approximately 1 nanometer and less than approximately 900 nanometers.
- 15. The method of Claim 1, wherein D is greater than approximately 5 nanometers and less than approximately 750 nanometers.
- 16. The method of Claim 1, wherein D is greater than approximately 10 nanometers and less than approximately 500 nanometers.
- 17. The method of Claim 1, wherein D is greater than approximately 40 nanometers and less than approximately 250 nanometers.
- 18. The method of Claim 1, wherein L is greater than approximately 0.5 micrometer and less than approximately 500 micrometers.
- 19. The method of Claim 1, wherein L is greater than approximately 6 micrometers and less than approximately 400 micrometers.
- 20. The method of Claim 1, wherein L is greater than approximately 500 micrometers.
- 21. The method of Claim 1, wherein the nanochannels are substantially straight and substantially parallel to one another.
  - 22. The method of Claim 1, wherein the nanochannels are coated.
- 23. The method of Claim 22, wherein the nanochannels are coated with a material selected from the group consisting of gold, platinum, and palladium.
- 24. The method of Claim 22, wherein the nanochannels are coated with a hydrophilic material.
- 25. The method of Claim 22, wherein the nanochannels are coated with a hydrophobic material.
- 26. The method of Claim 1, wherein the junction member is manufactured as a single planar element.
- 27. The method of Claim 1, wherein the junction member comprises a rigid support member.

- 28. The method of Claim 1, wherein the junction member is a laminate comprising at least one multiple planar element.
- 29. The method of Claim 28, wherein at least one of the multiple planar element is selected from the group consisting of a pressure sensor, a temperature sensor, a flow rate sensor, an electrical resistance sensor, a redox potential sensor, a conductivity sensor, and a pH sensor.
- 30. The method of Claim 1, wherein the junction member comprises a planar element of microchannels coupled to a planar element of nanochannels.
- 31. The method of Claim 30, wherein the planar element of microchannels is bonded to the planar element of nanochannels.
- 32. The method of Claim 30, wherein the planar element of the microchannels is thermally or adhesively bonded to the planar element.
- 33. The method of Claim 30, wherein the microchannels have widths greater than approximately 5 micrometers and less than approximately 25 micrometers.
- 34. The method of Claim 1, wherein the junction member is made of a polymer.
- 35. The method of Claim 34, wherein the polymer is selected from the group consisting of polycarbonate, polyethylene, and polyimide.
- 36. The method of Claim 1, wherein the junction member is made of silicon, glass, or ceramic.
- 37. The method of Claim 1, further comprising providing means for pressurizing the electrolyte solution.
- 38. The method of Claim 37, wherein the means for pressurizing is selected from the group consisting of a pressurized collapsible bladder, an electro-osmotic pump, a mechanical pump, a piezo-electric pump, and a electro-hydrodynamic pump.
- 39. The method of Claim 38, wherein the mechanical pump comprises a piston-driven pump.
- 40. The method of Claim 38, wherein the mechanical pump comprises a spring-loaded piston drive.
- 41. The method of Claim 1, further comprising providing a sensing electrode.

42. The method of Claim 41, wherein the sensing electrode is selected from the group consisting of pH electrodes, other ion-selective electrodes, and redox electrodes.